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Research Article

Programming multilevel crystallization states in phase-change-material thin films

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Abstract: We propose and demonstrate a simple method to accurately monitor and program arbitrary states of partial crystallization in phase-change materials (PCMs). The method relies both on the optical absorption in PCMs as well as on the physics of crystallization kinetics. Instead of raising temperature incrementally to increase the fraction of crystallized material, we leverage the time evolution of crystallization at constant temperatures and couple this to a real-time optical monitoring to precisely control the change of phase. We experimentally demonstrate this scheme by encoding a dozen of distinct states of crystallization in two different PCMs: GST and Sb₂S₃. We further exploit this 'time-crystallization' for the in-situ analysis of phase change mechanisms and demonstrate that the physics of crystallization in Sb₂S₃ is fully described by the so-called Johnson-Mehl-Avrami-Kolmogorov formalism. The presented method not only paves the way towards real-time and model-free programming of non-volatile reconfigurable photonic integrated devices, but also provides crucial insights into the physics of crystallization in PCMs.

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1. Introduction

Phase change materials (PCMs) are currently revolutionizing nanophotonics by providing ways to tune and reconfigure optical functionalities without any moving parts. The rapid rearrangement of atoms at the nanoscale translates into very large modifications of optical properties. Building on this phenomenon, the last decade has witnessed many exciting reports of novel devices exploiting PCMs such as for example beam-steering, tunable light emission, reflection and absorption, programmable metasurfaces and reconfigurable neural networks [1-11]. A large majority of the first studies were using PCMs as simple binary on-off switches, in which the ON state is the amorphous phase and the OFF state the fully crystalline phase. However, PCMs present another degree of freedom for tunability: the possibility to encode multilevel non-volatile states via partial crystallization. Recently, several works exploited this potential of PCMs for devices in waveguides, thin-films or metasurfaces [12-17]. Even though it may appear straightforward to prepare a thin-film to a desired level of partial crystallization – after all, one should just bring it to the correct temperature for a given duration – several issues make it a serious challenge to face. The main reason lies in the abruptness of the crystallization process, which may occur within nanoseconds after overcoming the temperature threshold for crystallization. Moreover, monitoring the progressive crystallization of a thin-film usually requires either sequential processes with destructive analysis (micrograph analysis of alloys or transmission electron microscopy) or spectral measurements whose acquisition time and analysis are typically longer than the timescale

of crystallization (X-ray diffraction, Raman or spectroscopic ellipsometry). Neither of these techniques are compatible with a real-time analysis of the crystalline fraction of a thin-film. In addition, most of the PCMs undergo a mechanical contraction (reduction of thickness) upon crystallization. This contraction could be as high as 20% and further complicates the analysis of crystallization fraction, given thickness and complex refractive index are correlated parameters when measured optically. However, both fundamental studies and future applications call for precise and rapid methods to analyze and program the crystalline fraction in PCMs thin-films.

Here, we propose a reliable, yet very simple method to program PCMs thin-films at a desired arbitrary crystalline fraction by following its state in real-time. To do so, we exploit both the optical absorption and the time-dependence of crystallization at temperatures near the threshold of crystallization. Additionally, we show that this method provides a way for the in-situ analysis of the crystallization mechanisms at play in PCM thin-films.

2. Principle and theory: breaking correlations

A standard method of analyzing the optical properties of PCMs in their different phases is to use spectroscopic ellipsometry coupled with a heat cell. Each state corresponding to a partial crystallization of the PCM is fitted to an oscillator model and the associated dispersion is then extracted (see e.g. [13,18]). However, the analysis is far from being straightforward as the PCMs usually go through a contraction upon their change of phase. It follows that two correlated parameters are simultaneously varying during this transition: the complex refractive index and the thickness. To illustrate how this double variation can seriously affect the analysis, we consider the normal incidence reflection of a 100-nm-thick Ge₂Sb₂Te₅ (GST) layer on a silicon substrate. We model the optical dispersion of the amorphous and crystalline phase using a Tauc-Lorentz model optimized from previous measurements [13] and the intermediate phases are modelled using a Bruggeman effective medium approximation mixing amorphous and crystalline phases in varying proportions (see Supplement 1 for more information). In Fig. 1(a) and (b), we show the separate contributions of thickness reduction and refractive index modulation - both due to a progressive crystallization - on the overall measured reflection. From the results displayed, it is clear that the two parameters affect differently the reflection and set challenges for the analysis, given thickness and refractive index are correlated parameters for optical measurements.

In most cases, this correlation can be lifted by adding another independent measurement to untangle the two contributions. For example, X-ray reflectivity can be used to precisely measure the thickness of the amorphous and crystalline phases and the measured values of thicknesses can then be fixed and no longer used as a free fit parameter in the ellipsometric models. Unfortunately, when one needs to follow crystallization in situ and in real-time this method is not suitable.

However, a close inspection to the reflection variations in Fig. 1 reveals a spectral region, below 500 nm, at which the reflection is insensitive to thickness modifications. The physical reason of this phenomenon is due to the optical absorption of GST: this spectral region falls above the bandgap of GST, which results in total absorption of light before it reaches the substrate. On the contrary, at the same wavelengths the reflection is strongly affected by refractive index variations. We therefore have a spectral region in which we can easily untangle the two correlated parameters and measure the sole contribution of refractive index modulations.



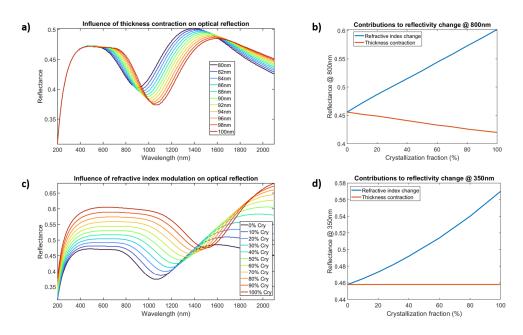


Fig. 1. Theoretical reflectivity of a 100-nm-thick GST film on silicon substrate at normal incidence a) Influence of a thickness contraction of 20% on the optical reflection and c) Influence of a refractive index change corresponding to the crystallization of the GST thin film. b) and d) Respective contributions of thickness contraction and refractive index modulation to reflectivity change at wavelengths of b) 800nm and d) 350 nm

3. Experimental results

3.1. Model-free real-time monitoring of crystallization

Following the crystallization in real time could thus be done by isolating conditions of optical measurements that are only sensitive to refractive index change and not to thickness modifications. However, crystallizing PCMs requires heating the materials above their crystallization temperatures. When dealing with temperature variations, there is another important factor to take into account: each materials present their own specific thermo-optic coefficients, resulting in non-straightforward modulations of optical properties as a function of temperature in multi-materials stacks. To circumvent these two additional sources of modulation (contraction and thermo-optical effects), we apply two simple rules: i) we measure the variation of optical properties at a fixed wavelength where the absorption in the PCM thin film is high enough to ensure the measured variations only depend on the refractive index of the PCM layer. ii) Instead of incrementally raising the temperature to progressively crystallize the PCM, we set the temperature to a fixed value close to the onset of crystallization and let the PCM crystallize as a function of time. Indeed, crystallization is based on the diffusion and re-arrangement of atoms through a temperature-activated process that typically follows an Arrhenius law. The diffusion length of atoms both depends on the diffusion coefficient and time: $l = \sqrt{Dt}$. Hence, progressive crystallization of materials can be produced at constant temperature. By following these guidelines, we rule out all parasitic contributions to optical modulations and ensure that the measured optical variations solely come from refractive index variation caused by the progressive crystallization of the PCM thin film.

We experimentally demonstrate this principle with two different PCMs: a 47-nm-thick GST layer deposited on silicon and capped with a 5-nm-thick SiO₂ layer, and an 180-nm-thick Sb₂S₃

layer on silicon capped with 55nm of SiO₂. All materials were deposited by e-beam evaporation at room temperature. For the optical monitoring, we use an ellipsometer (UVISEL, Horiba Jobin-Yvon) at a fixed incidence angle of 70° and measure the reflection at a single wavelength as a function of time for different temperatures, using a Linkam heat-cell with controlled temperature in air. The wavelengths and temperatures were set at 500 nm and 140°C for the GST sample and 435 nm and 260°C for the Sb₂S₃ sample. These temperatures were chosen such that the modifications of the measured parameters are slow enough to be easily monitored in time. Before reaching these values, the temperature was progressively raised, to ensure the thermal equilibrium is reached on the sample as soon as the crystallization temperature is set. As displayed in Fig. 2(a) and (b), we can see that the measured raw *Is* parameter (which is a combination of the Δ and Ψ ellipsometric angles – see Supplement 1 for more details) follows an exponential trend as a function of time and tends to an asymptotic value for both layers.

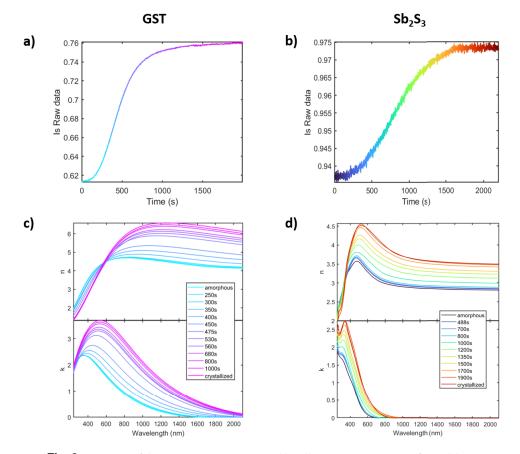


Fig. 2. Variation of the Is parameter as measured by ellipsometry versus time for a) GST at a temperature of 140° C and wavelength of 500 nm and b) Sb₂S₃ at a temperature of 260° C and a wavelength of 435 nm. For each PCM, the heating was stopped at different times and ellipsometry spectra were recorded at room temperature, resulting in the programming of multiple states of partial crystallization, as shown in the extracted dispersions for c) GST and d) Sb₂S₃.

As we have ruled out any other contributions to the modulation of the optical properties, the measured variations solely correspond to refractive index change of the PCMs through its progressive crystallization. To demonstrate this, we stop the crystallization by simply removing

the sample from the heat cell at various times, measure the ellipsometry spectra of the sample at room temperature and fit the measurements to a Tauc-Lorentz oscillator model (more details in the Supplement 1). As displayed in Fig. 2(c) and (d), we see that the progressive multilevel crystallization is confirmed and that we were able to program the states of both PCM films to more than ten different intermediate values of refractive index between the amorphous and crystalline ones. This process, when repeated several times, was proved reliable, with the same intermediate crystallization states obtained on different samples. We also directly confirm here that all intermediate partially crystallized states of Sb₂S₃ retain the ultralow optical absorption in the near-infrared region [19–22]. Note that all multilevel crystallization states dispersion data is available in Dataset 1 Ref. [23] and Dataset 2 Ref. [24]

This is the first major outcome of this report: by carefully selecting conditions for progressive crystallization, associated with real-time monitoring, we provide a simple and robust method to program a PCM thin-film in an arbitrary state of partial crystallization. This scheme only requires a light source with appropriate wavelength, a detector and a proper initial calibration, but neither require complicated optical setups with spectrometers and filters nor a model and associated fits for the analysis.

3.2. Analyzing crystallization mechanisms

In addition to providing a simple means to program the crystallization fraction in the PCM layers, this method also enables more fundamental insights into the crystallization mechanisms of PCMs. As described in the pioneering works of Johnson, Mehl, Avrami and Kolmogorov [25–29], change of phase proceeds via an active growth of transformation initiated around a nuclei. The volume of transformed material follows the so-called Johnson-Mehl-Avrami-Kolmogorov (JMAK) equation:

$$Y(t) = 1 - e^{(-q.t)^m}$$
(1)

where Y is the fraction of transformed material, ranging from 0 to 1, q is a time constant encompassing both the nucleation rate and the growth rate, which is a function of temperature and *m* an integer that depends on the nature of transformation (nucleation or growth-dominated, linear or polyhedral). In our case, the fraction of transformed material represents the progressively crystallized PCMs in an amorphous host of the same material. Normalizing our previously measured values of Is from 0 to 1 (i.e. fully amorphous to fully crystalline), we can use this JMAK equation to fit the experimental data and extract the values for q and m. This procedure is valid as long as the *Is* values linearly scale with the crystalline fraction (see the Supplement 1 for more information). In Fig. 3, we show the evolution of the crystalline fraction as a function of time for different temperatures in both GST and Sb₂S₃. As displayed in Fig. 3, it is possible to fit a significant part of the evolution of the crystalline fraction for both PCMs at all temperatures with this formalism. Let us first focus on the GST layer. It is clear from the comparison between fits and experimental data that the JMAK model is insufficient to fully describe the whole transformation from amorphous to fully crystalline GST. This result is consistent with previous reports showing that GST-225 only partially complies with the approximations of the JMAK model [30]. Indeed, the JMAK model is only valid if the nucleation sites are homogeneously distributed in the layer and if the growth rate is constant. Two conditions that are known to not be fulfilled in GST. However, the part of the transformation that immediately follows the incubation time and until about 75% of the transformation indeed follows a JMAK evolution, with a value of m = 2.5. By fitting this part, we extract values of q that are plotted in the inset of figure 3a) which are fitted with an Arrhenius law. This analysis enables the extraction of an activation energy $E_a=2$ eV that is perfectly in line with previous studies [31].

On the other hand, the progressive crystallization of Sb_2S_3 is remarkably well fitted by the JMAK model throughout its transformation and for all studied temperatures, with a constant value of m = 2.2. Fitting the obtained q values at different temperatures with the Arrhenius law,

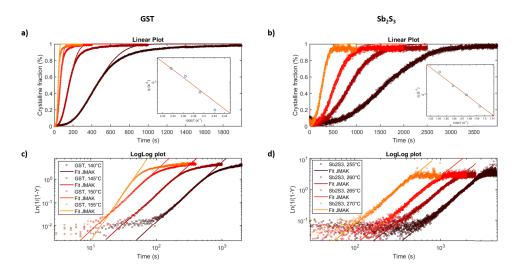


Fig. 3. Crystalline fraction evolution as a function of time for four different temperatures for GST (a) linear plot, c) loglog plot and Sb_2S_3 (b) linear plot and d) loglog plot. Insets in a) and b) are Arrhenius plots of the q factor versus 1000/T.

we extract an activation energy of $E_a=2.67$ eV for the crystallization of Sb₂S₃. This result implies that Sb₂S₃ layers fully respect the approximations of the JMAK model, that is: a randomly and homogeneously distributed apparition of nucleation sites, as well as a constant nucleation and growth rate. To the best of our knowledge, we report here for the first time that the JMAK formalism perfectly applies to the crystallization of Sb₂S₃.

4. Discussion

We have seen that combining a careful selection of wavelength for real-time monitoring of PCMs and constant temperature for gradual crystallization not only enables precisely programming them to arbitrary crystalline fractions, but also to have deeper insights on the physics at play in the transformation. While the scope of the study reported here was to present the method and highlight its usefulness, future works should capitalize on it for several important studies. First of all, PCMs are unique not only because of their changes in physical properties upon crystallization, but also because of their reversibility. This reversibility includes cycles of crystallization-amorphization process with volume expansion and contraction [31,32]. It is then crucial to rule out the thickness dependence from the analysis and therefore our proposed method will have a clear impact on decorrelating the thickness modulation from the real-time measurements of optical properties. By combining different probe wavelengths for measurements, one could untangle the potentially different dynamics associated to crystallization and thickness contraction. Not to mention that in-situ monitoring is also mandatory when there are spatial variations of crystalline domains: different properties may arise with respect to the exact device location, because of the random apparition of nucleation sites.

There are also a large number of situations in which a real time analysis such as the one presented here is mandatory. For example, as physical properties of PCM depend on various factors such as stoichiometry, thickness, volume, substrate and capping layer, one could either or both use this method as a model-free method to program PCMs at arbitrary levels of crystallization, or to analyze the influence of these factors in the physics of the change of phase. Future studies could for example exploit this method to analyze and measure the influence of the capping layer on the crystallization process and thickness variation of the PCMs. On a more fundamental level,

the presented method could be exploited to study the fundamentals of phase change and their links to different stimuli and introduction of defects [33].

5. Conclusion

We have presented and experimentally demonstrated a method to follow in real time the progressive crystallization of PCMs. This in-situ monitoring was first exploited to program both GST and Sb_2S_3 to arbitrary fractions of crystallization, hence enabling a robust and model-free method to encode multiple intermediate levels in the optical properties of these PCMs. Furthermore, as this transformation monitoring rules out the contributions of thickness modifications and thermo-optic effects, we exploited it for deeper analysis of the physics of phase change in these materials. By doing so, we provide for the first time direct experimental evidences that the progressive crystallization of Sb_2S_3 exactly follows the Johnson-Mehl-Avrami-Kolmogorov formalism. Therefore, the simple yet robust method presented here provides a very interesting pathway for both engineering devices and obtaining fundamental insights in the physics of phase transformation.

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Disclosures. The authors declare no conflicts of interest.

Data Availability. Data underlying the results presented in this paper are publicly available at Dataset 1 [23] and Dataset 2 [24].

Supplemental document. See Supplement 1 for supporting content.

References

- M. Wuttig, H. Bhaskaran, and T. Taubner, "Phase-change materials for non-volatile photonic applications," Nat. Photonics 11(8), 465–476 (2017).
- S. Abdollahramezani, O. Hemmatyar, and H. Taghinejad, *et al.*, "Tunable nanophotonics enabled by chalcogenide phase-change materials," Nanophotonics 9(5), 1189–1241 (2020).
- 3. S. Cueff, J. John, and Z. Zhang, et al., "VO2 nanophotonics," APL Photonics 5(11), 110901 (2020).
- C. R. de Galarreta, A. M. Alexeev, and Y.-Y. Au, *et al.*, "Nonvolatile reconfigurable phase-change metadevices for beam steering in the near infrared," Adv. Funct. Mater. 28(10), 1704993 (2018).
- S. Cueff, D. Li, and Y. Zhou, *et al.*, "Dynamic control of light emission faster than the lifetime limit using VO₂ phase-change," Nat. Commun. 6(1), 8636 (2015).
- J. Feldmann, N. Youngblood, and C. D. Wright, et al., "All-optical spiking neurosynaptic networks with self-learning capabilities," Nature 569(7755), 208–214 (2019).
- J. Feldmann, N. Youngblood, and M. Karpov, *et al.*, "Parallel convolutional processing using an integrated photonic tensor core," Nature 589(7840), 52–58 (2021).
- A. Tripathi, J. John, and S. Kruk, *et al.*, "Tunable mie-resonant dielectric metasurfaces based on VO₂phase-transition materials," ACS Photonics 8(4), 1206–1213 (2021).
- Z. Fang, R. Chen, and J. Zheng, *et al.*, "Ultra-low-energy programmable non-volatile silicon photonics based on phase-change materials with graphene heaters," Nat. Nanotechnol. 17(8), 842–848 (2022).
- Y. Zhang, C. Fowler, and J. Liang, *et al.*, "Electrically reconfigurable non-volatile metasurface using low-loss optical phase-change material," Nat. Nanotechnol. 16(6), 661–666 (2021).
- P. Moitra, Y. Wang, and X. Liang, *et al.*, "Programmable wavefront control in the visible spectrum using low-loss chalcogenide phase-change metasurfaces," Adv. Mater. 35(34), e2205367 (2023).
- C. Ríos, M. Stegmaier, and P. Hosseini, *et al.*, "Integrated all-photonic non-volatile multi-level memory," Nat. Photonics 9(11), 725–732 (2015).
- S. Cueff, A. Taute, and A. Bourgade, *et al.*, "Reconfigurable flat optics with programmable reflection amplitude using lithography-free phase-change material ultra-thin films," Adv. Opt. Mater. 9(2), 2001291 (2021).
- E. Mikheeva, C. Kyrou, and F. Bentata, et al., "Space and time modulations of light with metasurfaces: Recent progress and future prospects," ACS Photonics 9(5), 1458–1482 (2022).
- X. Li, N. Youngblood, and C. Ríos, *et al.*, "Fast and reliable storage using a 5 bit, nonvolatile photonic memory cell," Optica 6(1), 1–6 (2019).
- N. Farmakidis, N. Youngblood, and J. S. Lee, *et al.*, "Electronically reconfigurable photonic switches incorporating plasmonic structures and phase change materials," Adv. Sci. 9(20), 2200383 (2022).

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- R. Chen, Z. Fang, and C. Perez, *et al.*, "Non-volatile electrically programmable integrated photonics with a 5-bit operation," Nat. Commun. 14(1), 3465 (2023).
- Y. Gutiérrez, S. Espinoza, and M. Zahradník, et al., "Characterizing optical phase-change materials with spectroscopic ellipsometry and polarimetry," Thin Solid Films 763, 139580 (2022).
- W. Dong, H. Liu, and J. K. Behera, *et al.*, "Wide bandgap phase change material tuned visible photonics," Adv. Funct. Mater. 29(6), 1806181 (2019).
- M. Delaney, I. Zeimpekis, and D. Lawson, *et al.*, "A new family of ultralow loss reversible phase-change materials for photonic integrated circuits: Sb₂S₃ and Sb₂Se₃," Adv. Funct. Mater. **30**(36), 2002447 (2020).
- Z. Fang, J. Zheng, and A. Saxena, *et al.*, "Non-volatile reconfigurable integrated photonics enabled by broadband low-loss phase change material," Adv. Opt. Mater. 9(9), 2002049 (2021).
- 22. Y. Gutiérrez, A. P. Ovvyan, and G. Santos, *et al.*, "Interlaboratory study on Sb₂S₃ interplay between structure, dielectric function, and amorphous-to-crystalline phase change for photonics," iScience **25**(6), 104377 (2022).
- S. Cueff, "Dispersion dataset of all crystallization states of gst.xlsx," figshare (2023).https://doi.org/10.6084/m9.figshare.23627865.v1.
- S. Cueff, "Dispersion dataset of all crystallization states of sb2s3.xlsx," figshare (2023).https://doi.org/10.6084/m9.figshare.23627868.v1.
- 25. W. Johnson, "Rf: Trans," Am. Inst. Min. (Metall Eng.) 135, 416 (1939).
- 26. M. Avrami, "Kinetics of phase change. i general theory," The J. Chem. Phys. 7(12), 1103–1112 (1939).
- 27. M. Avrami, "Kinetics of phase change. ii transformation-time relations for random distribution of nuclei," The J. Chem. Phys. 8(2), 212–224 (1940).
- 28. M. Avrami, "Granulation, phase change, and microstructure kinetics of phase change. iii," The J. Chem. Phys. 9(2), 177–184 (1941).
- 29. A. Kolmogorov, "On the static theory of crystallization in metals," Bull Acad Sci USSR, Phys Ser 1, 335 (1937).
- S. Senkader and C. Wright, "Models for phase-change of Ge₂Sb₂Te₅ in optical and electrical memory devices," J. Appl. Phys. 95(2), 504–511 (2004).
- V. Weidenhof, I. Friedrich, and S. Ziegler, *et al.*, "Laser induced crystallization of amorphous Ge₂Sb₂Te₅ films," J. Appl. Phys. 89(6), 3168–3176 (2001).
- 32. S. Raoux, "Phase change materials," Annu. Rev. Mater. Res. 39(1), 25-48 (2009).
- L. Jin, Y. Shi, and F. I. Allen, *et al.*, "Probing the critical nucleus size in the metal-insulator phase transition of VO₂," Phys. Rev. Lett. **129**(24), 245701 (2022).